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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10074884	FILING DATE 02/13/2002	CLASS 438	SUBCLASS 635	GAU 2810	EXAMINER Erdem
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**APPLICANTS: Ramkumar Krishnaswamy;						
**CONTINUING DATA VERIFIED:						
** FOREIGN APPLICATIONS VERIFIED:						
PG-PUB	DO NOT PUBLISH <input checked="" type="checkbox"/>	RESCIND <input type="checkbox"/>				
Foreign priority claimed		<input type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO			
35 USC 119 conditions met		<input type="checkbox"/> yes <input type="checkbox"/> no	5298-08000 PM01040			
Verified and Acknowledged Examiners's initials						
TITLE : Semiconductor topography including a thin oxide-nitride stack and method for making the same						U.S. DEPT. OF COMM /PAT./& TM-PTO-436L(Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G
ISSUE FEE		DRAWING		
Amount Due	Date Paid	Sheets Drwg.	Figs.Drwg.	Print Fig.
TERMINAL DISCLAIMER		Primary Examiner		
		Application Examiner		
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